LIQUID MATERIAL VAPORIZATION APPARATUS AND OPERATION SETTING METHOD THEREOF

ABSTRACT

A liquid material vaporization apparatus operates such that, in a gas generation mode, a liquid material is supplied to a tank 1 through a supply path R1 via a first on-off valve V1 set to a predetermined first opening degree, and operates such that, in a purge mode, a purge gas is introduced into the tank 1 through the supply path R1 via the first on-off valve V1 set to a second opening degree that is larger than the first opening degree.

Fig. 1